



Review of Printed Electrodes for Flexible Devices

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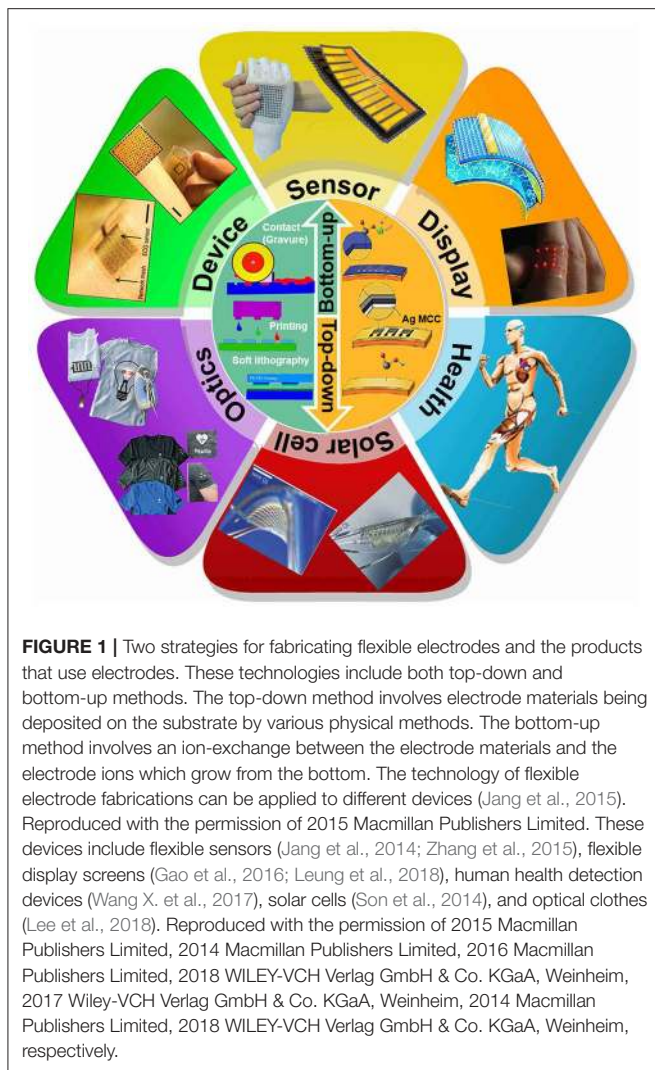
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Printed electronic technologies draw tremendous attention worldwide due to their ability to surpass the limitations of traditional high-cost electronics, based on rigid silicon, and the manufacturing of various devices on flexible substrates. As a critical component of flexible electronics, electrodes fabricated on soft, bendable, and stretchable substrates are of great importance. Based on the fabrication process, this paper classifies the mainstream technologies into two categories: top-down and bottom-up. Top-down technologies include physical evaporation methods, printing technologies and soft lithography, while bottom-up technologies involve polymer-assisted-metal-deposition methods and ion-exchange methods, respectively. In contrast to top-down technologies that transfer functional ink onto substrates directly, the bottom-up method achieves a great improvement in the adhesion between substrates and metal electrodes. In this paper, the challenges of top-down technologies, including cost, synthesis, and choice of ink for printing technologies, the limited choice of metal for bottom-up technologies and the mass production of these methods, are also discussed.

Keywords: printed electrodes, flexible devices, electronic devices, metal nanomaterials, ion-exchange technology

INTRODUCTION

Increasing demand for high performance devices, drives the development of alternative, or novel structures of devices and the use of new materials (Liu et al., 2017; Wang et al., 2018). In recent years, flexible and stretchable electronics have developed at an unprecedented rate and are involved in various applications, including sensors (Chu et al., 2018; Pan et al., 2018), displays (Chen et al., 2017), solar cells (Wang C. et al., 2017; Xi et al., 2017; Zhang et al., 2017), supercapacitors (Li J. et al., 2017; Wang M. et al., 2017), electronic skins (E-skins) (Lou et al., 2017; Bermúdez et al., 2018; Byun et al., 2018) and wearable electronics (Lee et al., 2017). Some applications are shown in **Figure 1**. In terms of substrates, conventional silicon, and mature technologies have attained micro structures and ultrathin chips, which strengthen its flexibility (Lin C. C. et al., 2017; Navaraj et al., 2018). However, compared with this complicated process, the method for fabricating devices directly on the soft, bendable and skin-mounted polymer substrates, such as polyethylene (PE) and terephthalate (PET) is more advantageous. In the realization process of the devices mentioned above, a key challenge in producing electrodes, with high conductivity and good flexibility, exists. To solve this problem, some solutions are being developed. These solutions include conventional technologies derived from mature technologies for silicon substrates, such as physical vapor deposition, printing technologies such as screen and inkjet printing technologies, and roll-to-roll technology, spin-coating method, and other technologies that contain chemical procedures.



Depending on the fabrication of electrodes, the subsistent technologies are classified into two categories: the top-down and bottom-up. The aim of this paper is to review the current processes of fabricating flexible electrodes within these two categories. As shown in **Figure 2**, top-down methods include traditional technologies, printing technologies and soft lithography, while the bottom-up method includes the polymer-assisted-metal-deposition (PAMD) technology and ion-exchange technology. To be specific, top-down methods use physical methods to pile electrode material up on the substrate. In other words, electrode material originates from the source above the substrates and is deposited on the substrate, most of which is a physical process. In contrast, bottom-up methods use chemical methods to fabricate flexible electrodes. Take the ion-exchange method as an example, the substrate is processed by a chemical method to an ion exchange between the electrode material and the substrate. Some ions of the electrode materials replace the ions of the substrate. The ions of the electrode material grows upward and forms the electrodes. Furthermore, **Figure 1** lists the various products that use the technology of flexible

electrode fabrication. The flexible electrodes can be applied to flexible devices. Flexible devices include sensors, display screens and solar cells (Son et al., 2014). These devices can be used to compose wearable devices that can monitor human health. Flexible electrodes are capable of working in a variety of applications. Fabricating high-performance flexible electrodes is necessary during the development of electronic devices.

THE TOP-DOWN TECHNOLOGIES OF PRINTED ELECTRODES

Conventional Technologies

Physical Evaporation Deposition

The traditional production process for RFID antennas is demonstrated in **Figure 3A** (Wu, 2017). The fabrication process, based on rigid silicon substrates, involves complicated steps as well as the use of chemical reagents. Contrarily, due to the common character of flexible substrates that cannot bear high temperature and reagent corrosion, the preparation of electrodes on flexible substrates is usually simple. Nonetheless, depending on the mature production technology, traditional methods of fabricating electrodes are still informative and compatible with electrodes on flexible substrates. Physics vapor deposition (PVD), which includes three main techniques, evaporation, sputtering and electron beam irradiation (e-beam), is one of the most popular methods for depositing metal electrodes. As shown in **Figures 3B,C**, Yeongin Kim et al. reported a bioinspired flexible organic artificial afferent nerve, which includes a core composed of organic ring oscillators (Kim et al., 2018). In the process of producing the organic ring oscillators, Ti/Al were deposited as gate electrodes and patterned Cr/Au were deposited as source/drain electrodes, both of which were fabricated by e-beam. Sungjun Park et al. reported fabricating self-powered, ultra-flexible electronics via nanograting-patterned organic photovoltaics, with deposited 100 nm indium tin oxides (ITO) electrode (Park et al., 2018). These widely-used traditional technologies are compatible with the production of flexible electrodes. In addition, by relying on these mature physical techniques, the fabricated electrodes pose a high nanoscale solution and relatively high conductivity, which is suitable for refined applications. It is therefore noteworthy that the deposition of metal is usually a one-step deposition. In classic top-down methods for depositing metal on flexible substrates, the physical adhesion between the electrodes and the substrates is usually weaker than those fabricated with the bottom-up methods.

Dip-Pen Technology

The mechanism of the dip-pen nanolithography can be described as ink molecules that attach to the tip of the atomic force microscope and are gradually transferred to the surface of the substrate, to achieve controllable patterns with the assistance of the capillary action and surface tension of the water droplets between the tip and the base. Lina et al reported fabricating the Au nanostructure array using the dip-pen method as a desktop fabrication tool, making it possible for high-throughput and arbitrary patterns in an ambient condition (Chen et al.,

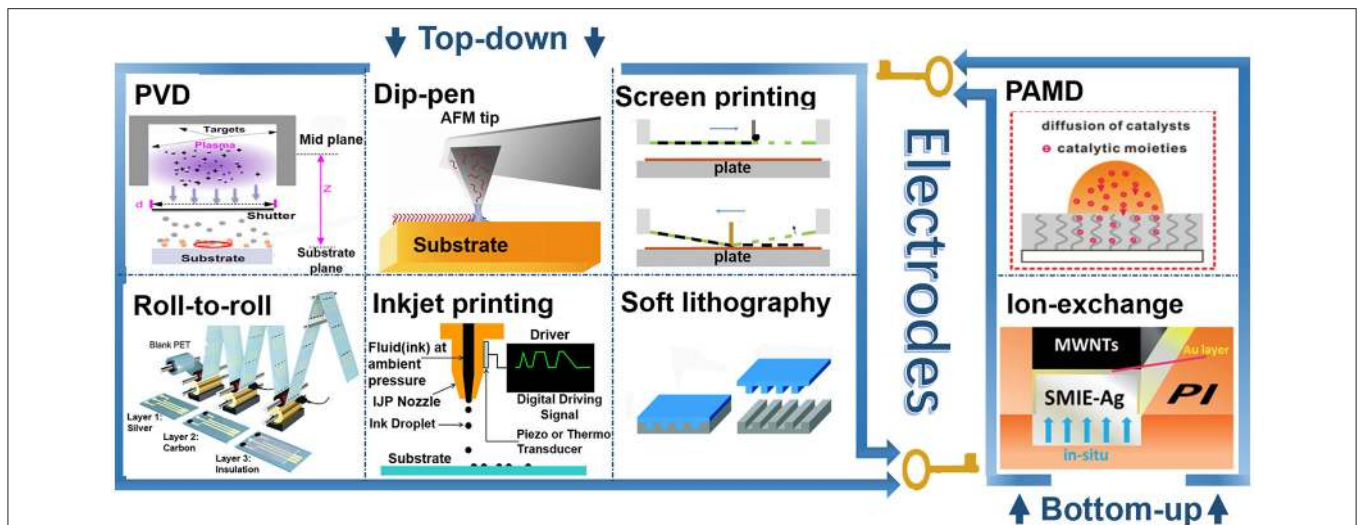


FIGURE 2 | The technologies for electrode fabrication, including two categories based on the manufacture process: **top-down** and bottom-up. Top-down technologies involving the physical evaporation deposition (Sahu et al., 2018), dip-pen nanolithography, (Wixforth et al., 2009), screen printing technology (Li W. et al., 2017), roll-to-roll technology (Bariya et al., 2018), inkjet printing technology (Xu et al., 2007), and the soft lithography (Wisser et al., 2015). Reproduced with the permission of 2018 Springer Nature Limited, SPIE Europe Microtechnologies, The Royal Society of Chemistry 2017, 2018 American Chemical Society, SPIE Europe Microtechnologies, The Royal Society of Chemistry 2015.

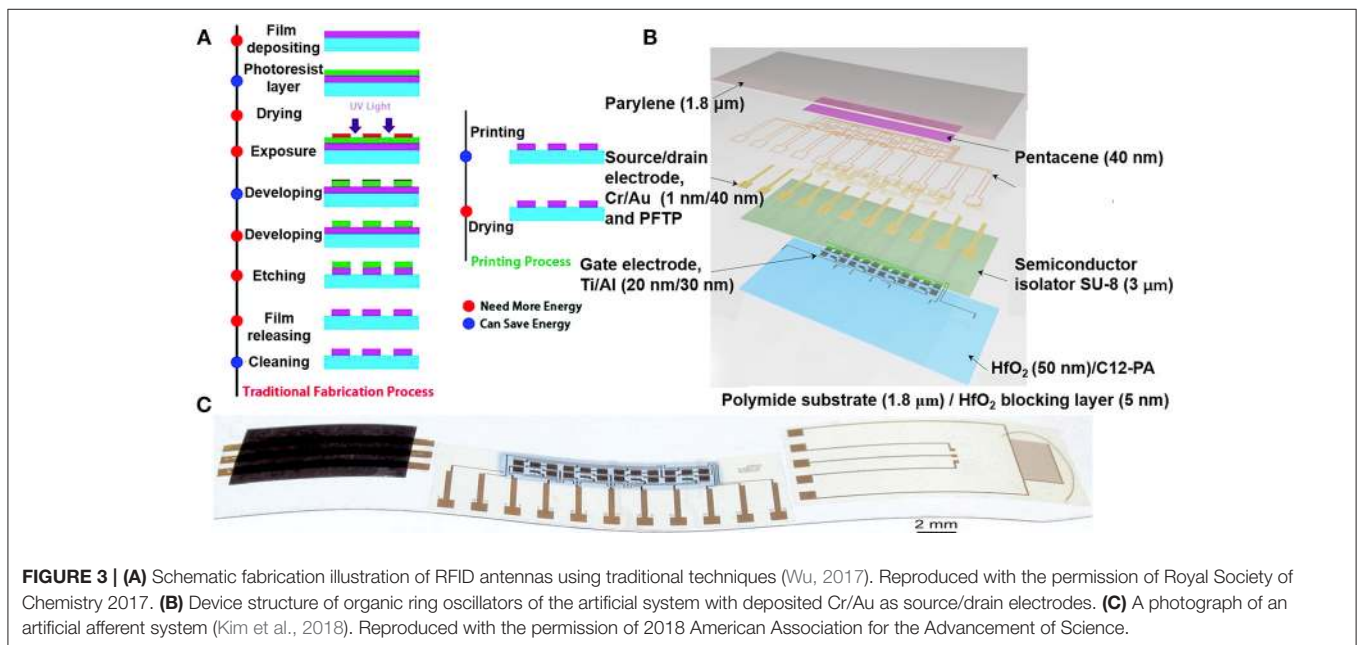
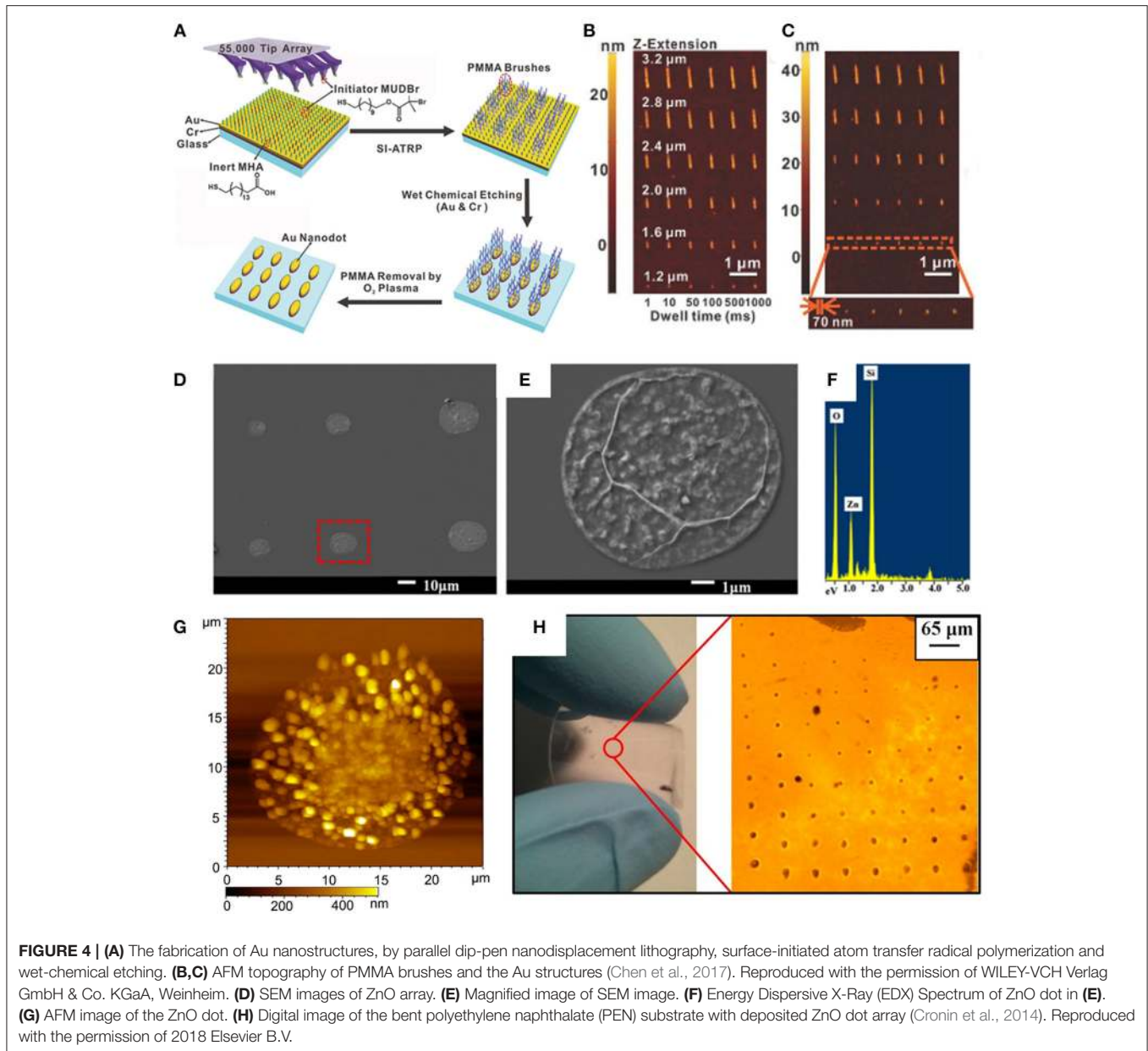


FIGURE 3 | (A) Schematic fabrication illustration of RFID antennas using traditional techniques (Wu, 2017). Reproduced with the permission of Royal Society of Chemistry 2017. (B) Device structure of organic ring oscillators of the artificial system with deposited Cr/Au as source/drain electrodes. (C) A photograph of an artificial afferent system (Kim et al., 2018). Reproduced with the permission of 2018 American Association for the Advancement of Science.

2017). **Figure 4A** is the fabrication diagram of Au structure employing the dip-pen technology. **Figure 4B** shows the atomic force microscope (AFM) topography of PMMA brushes under various patterning conditions, which is employed as a mask for chemical etching in the fabrication procedures shown in **Figure 4A**. **Figure 4C** shows the AFM topography of resulting Au structures. Cronin et al reported fabricating the ZnO dot array on the flexible PE substrates (Cronin et al., 2014). **Figure 4D** is the scanning electron microscope (SEM) image of the ZnO dot

with a $\sim 10 \mu\text{m}$ diameter. **Figure 4E** is the enlarged SEM image of sample shown in **Figure 4D**. The EDX area analysis validates the presence of Zn and O shown in **Figure 4F**. The AFM image of the dot is shown in **Figure 4G**, demonstrating the roughness of the dot fabricated with ZnO ink. In addition, it can be observed that the maximum size of the fabricated dot is $\sim 350 \text{ nm}$. In **Figure 4H**, the bent PE substrate and conducting ZnO array is displayed, after a versatile transfer process, and illustrates the enlarged view of the patterned arrays, to the right.



Printing Technologies

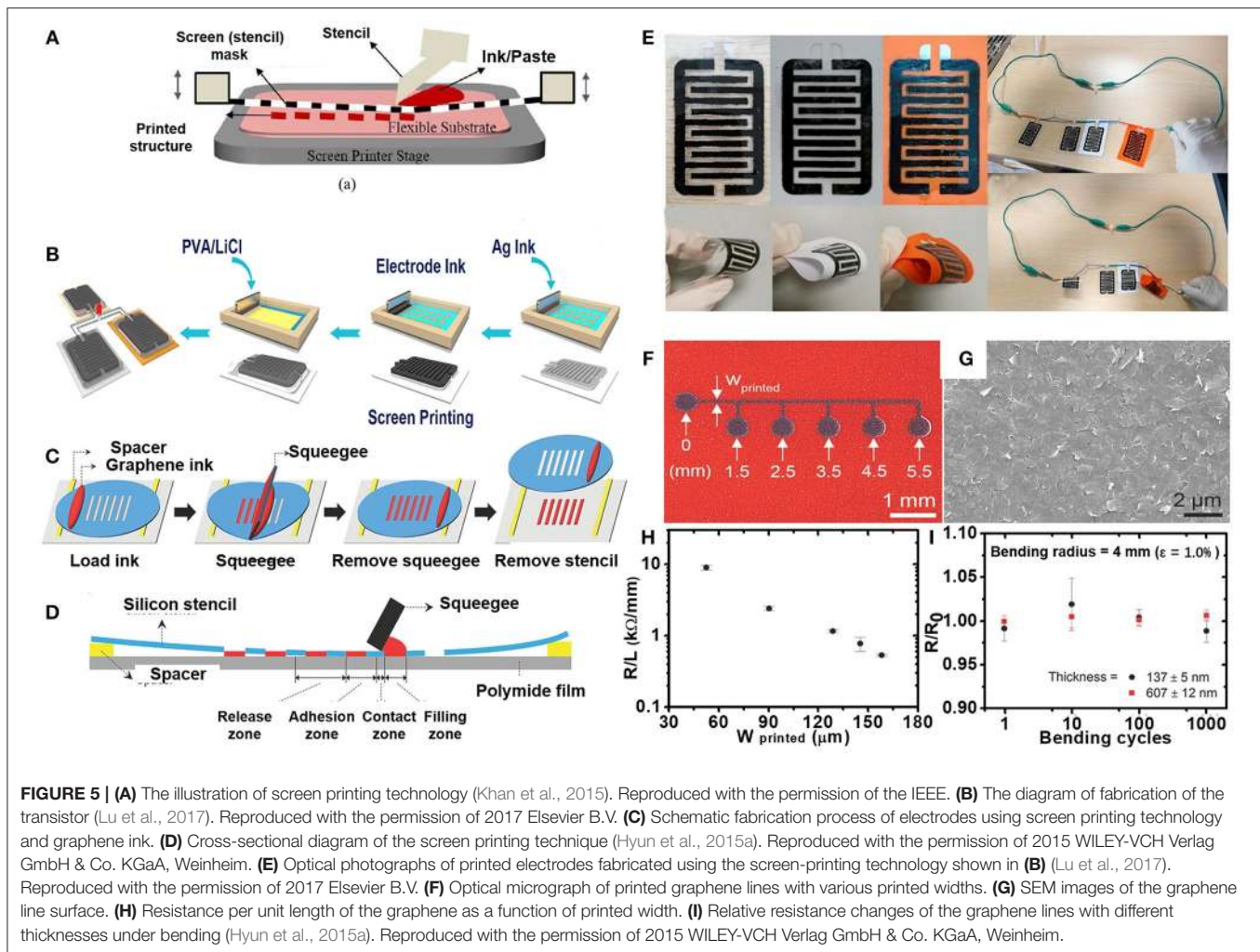
Due to high costs and the demanding requirements of machines for the electrodes fabricated by conventional technologies, low-cost fabrication methods are desired. Here, low cost, high efficiency printing fabrication processes are reviewed.

Screen Printing Technology

In this relatively mature technology, shown in **Figure 5A**, there are five core components including a stencil with meshes, a squeegee, functional ink, a screen printer stage and substrate. As shown in **Figures 5B,C**, the procedure of screen-printing involves two main steps: the penetration of functional ink through the mesh in the stencil and the deposition onto the

substrate, thereby forming the requisite patterned electrodes. The cross-section process of screen-printing technology is demonstrated in **Figure 5D**.

Employing screen-printing technology, Qiang Lu et al. reported synthesizing composites of FeOOH/MnO₂ as ink and fabricating all printed solid-state flexible supercapacitors (Lu et al., 2017). Due to the flexibility of PET, paper and textile as substrates, the supercapacitors are bendable as shown in **Figure 5E**. An experiment of illuminating a yellow LED, using printed electrodes, is also shown in **Figure 5E**. In addition to the composites of FeOOH/MnO₂, graphene ink used in screen-printing technology has been reported by Hyun et al. (2015a). To improve the solution of graphene electrodes, a new way of making stencils was developed. A silicon wafer was

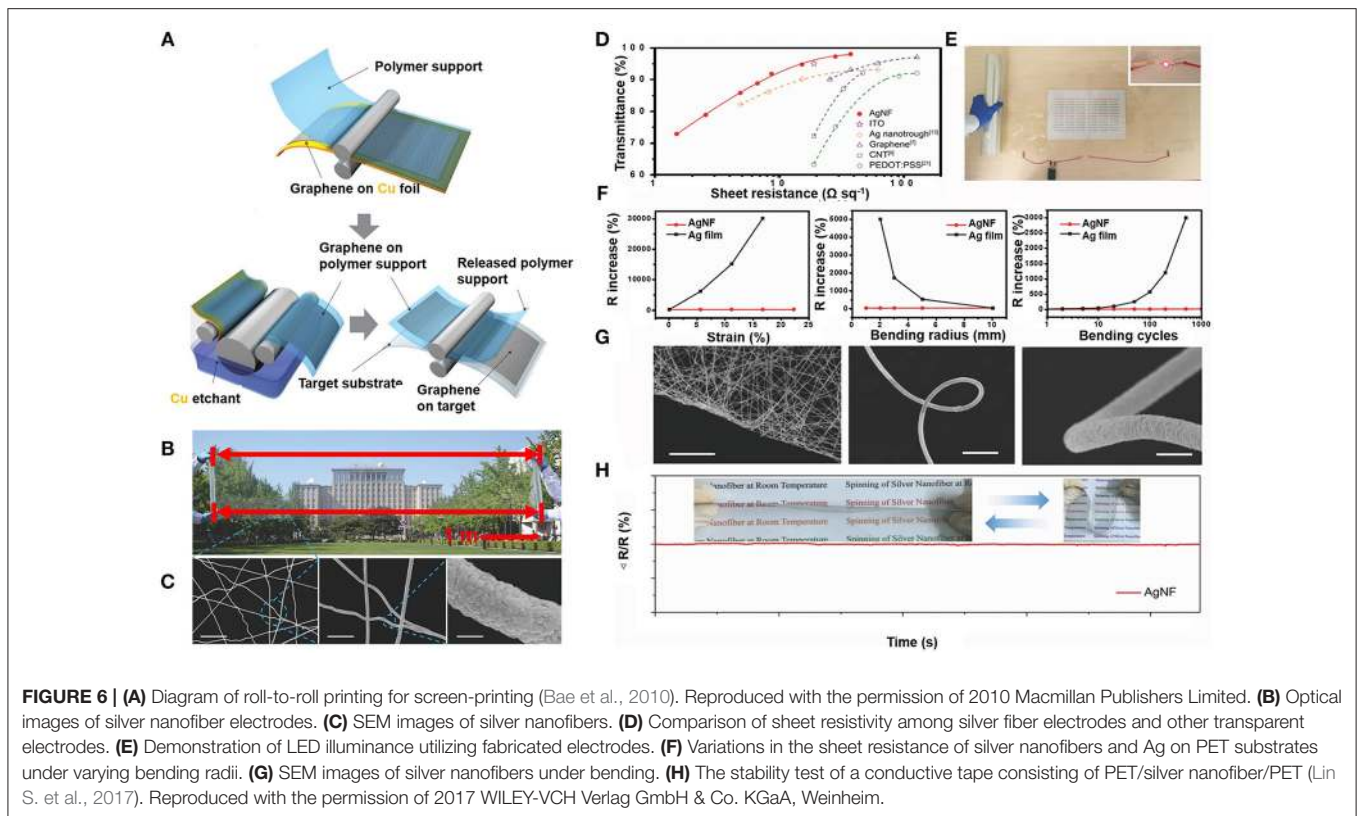


thinned to $120\ \mu\text{m}$ and then photolithography was carried out to pattern the surface with openings of various widths. The optical micrographs of printed graphene electrodes with varying widths and SEM images of the graphene electrode surface are shown in **Figures 5F,G**, respectively. The roughness of the electrodes was measured as $\sim 32\ \text{nm}$ using atomic force microscopy (AFM). **Figure 5H** focuses on the changes in resistance with different printed widths. The stability of electrodes under bending and releasing cycles is displayed in **Figure 5I**, shows the great bending stability of printed graphene, independent of the printed line widths. Limited to the penetration and block mechanism, patterned electrodes have the ability to transfer shapes accurately with the opening. Benefiting from a relatively simple procedure, feasibility of mass production, changeable patterns and low cost, screen printing technology is one of the most popular methods to fabricate electrodes on flexible substrates. Similar to the traditional method of fabricating electrodes, screen-printing technology also falls under the top-down methods. Due to the weak connection between the ink and the substrate, the viscosity and squeegee play a significant role in the solution.

Roll-To-Roll Technology

To satisfy the increasing need for industrial manufacturing, the roll-to-roll printing technology has been developed over the past years. Roll-to-roll printing technology features mass and pipeline production techniques that are put into use in a printed circuit board.

With functional ink printed onto flexible substrates, this physical fabrication process is also a type of top-down method. Bae et al reported using a roll-to-roll printing technology to fabricate transparent graphene electrodes as illustrated in **Figure 6A** (Bae et al., 2010). The whole process of fabrication involves three essential steps: adhesion of the polymer support to the graphene, removal of the Cu foil by etching, and release of the polymer support and transfer of the graphene onto the target substrates. A 30-inch graphene electrode film can be fabricated with a resistance of $\sim 125\ \Omega^{-1}$ and 97.4% optical transmittance. In addition to the graphene, silver nanofiber ink is also employed to print electrodes. **Figure 6B** is a digital photograph of silver nanofiber electrodes using roll-to-roll technology, demonstrating its character of transparency and larger-size. SEM images of silver nanofibers are shown in **Figure 6C**. In **Figure 6D**,

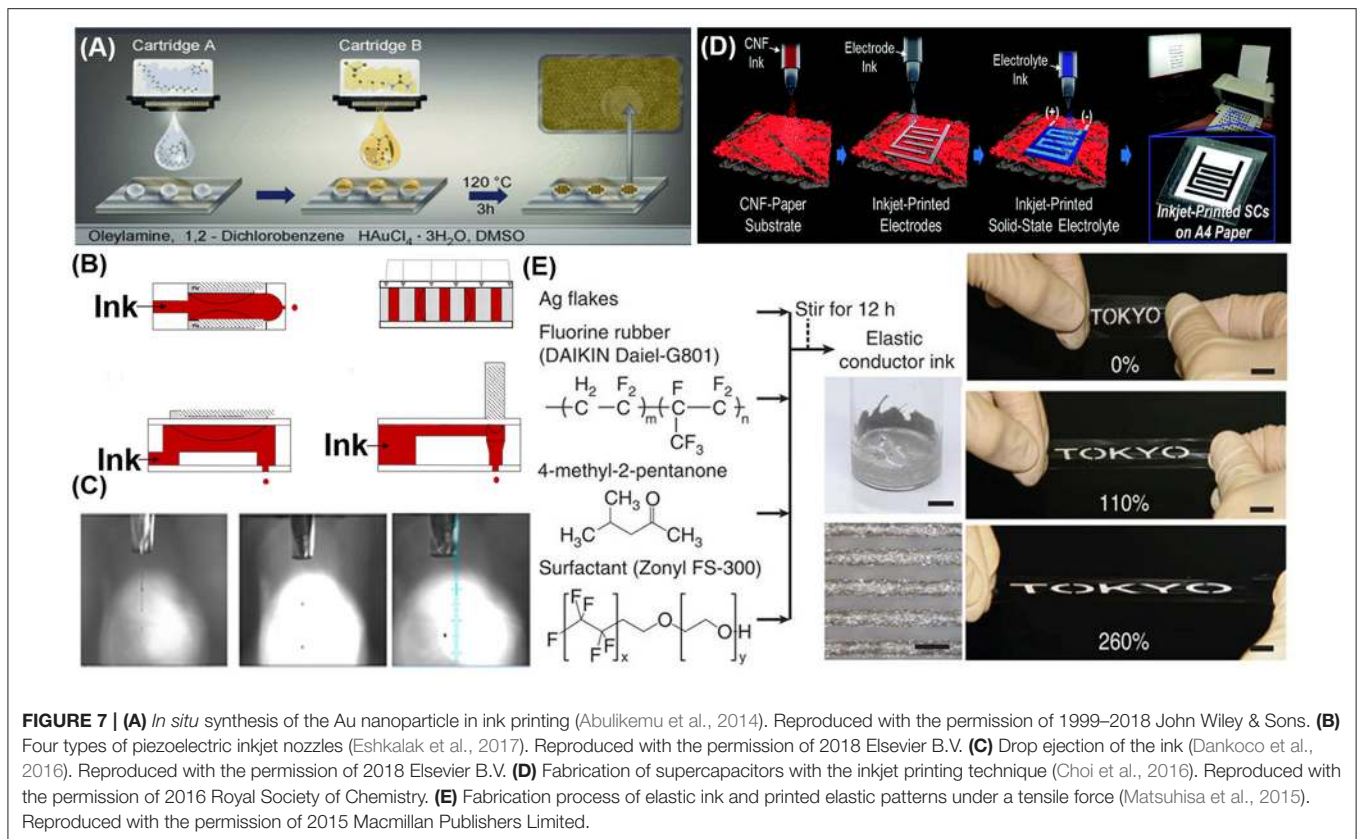


it can be observed that compared with other transparent electrodes, such as ITO, Ag nanotrough, graphene, carbon nanotubes and PEDOT:PSS, the fabricated electrodes have the advantage of transmittance and sheet resistance. In addition, by adjusting the spray time of the ink, the transmittance can be controlled. The demonstration of the experiment of LED illumination is shown in **Figure 6E**. Compared with the Ag film, the silver nanofiber has greater mechanical stability and conductivity under consecutive stretching and bending shown in **Figure 6F**. Benefiting from the intrinsic flexibility shown in the SEM images of **Figure 6G**, the nanofiber electrodes can bear over 2,000 s of bend and release cycles while maintaining the resistance, as shown in **Figure 6H**. Using the roll-to-roll fabrication technology, functional ink can be printed onto the substrate, forming flexible electrodes in a highly efficient way. The fabricated electrodes maintain a high transmittance and excellent flexibility while possessing a relatively high conductivity, which is very beneficial for display applications. Maintaining high productivity and high n at the same time is the predominant advantage of roll-to-roll technology, which can meet the demanding needs of mass production. The same can be said for other physical processes, where the electrodes show a relatively weak adhesion with the flexible substrates.

Inkjet Printing Technology

In contrast to the screen-printing technology, with patterns limited by the squeegee, the top-down fabrication of inkjet

printing is one of the “direct writing” technologies with its patterns controlled by computer programs directly. Without being limited to specific patterns, this technology is suitable for customized electrodes. The synthesis of conductive ink is one of the core parts of inkjet printing technology. **Figure 7A** illustrates the *in situ* fabrication of the Au nano-conductive particle ink (Abulikemu et al., 2014). Based on the mechanism of the piezoelectric inkjet printer, which contains a transducer in the nozzles and under the pressure of voltage, it generates the functional ink droplet sparged out of the nozzle. Depending on the shape of the piezoelectric transducer and its various ways of forcing, there are four main piezoelectric types; squeeze, shear, bend, and push as shown in **Figure 7B**, respectively. The droplet formation sequence from the nozzle of the inkjet printer is shown in **Figure 7C**. Inkjet printing technology was employed to fabricate the supercapacitors displayed in **Figure 7D**. It is noteworthy that the electrodes were printed with composite ink of single wall carbon nanotubes and active carbon. Naiji Matsuhisa et al reported synthesizing a conductor of Ag flakes, a fluorine rubber and a fluorine surfactant as ink for textile electrodes. **Figure 7E** illustrates the components of the ink and stretchability of patterned conductors. Breaking the limitation of settled patterns, the printing technology has great advantages in arbitrary shapes of electrodes. Nevertheless, on one hand, similar to the screen-printing technology, the functional ink is transferred to the substrates through physical means, which results in a weaker connection compared with bottom-up fabrication methods. On



the other hand, to improve the conductivity of the electrodes, the sintering step is crucial, which is equal to high-power consumption.

Combination of Screen and Inkjet Printing Technologies

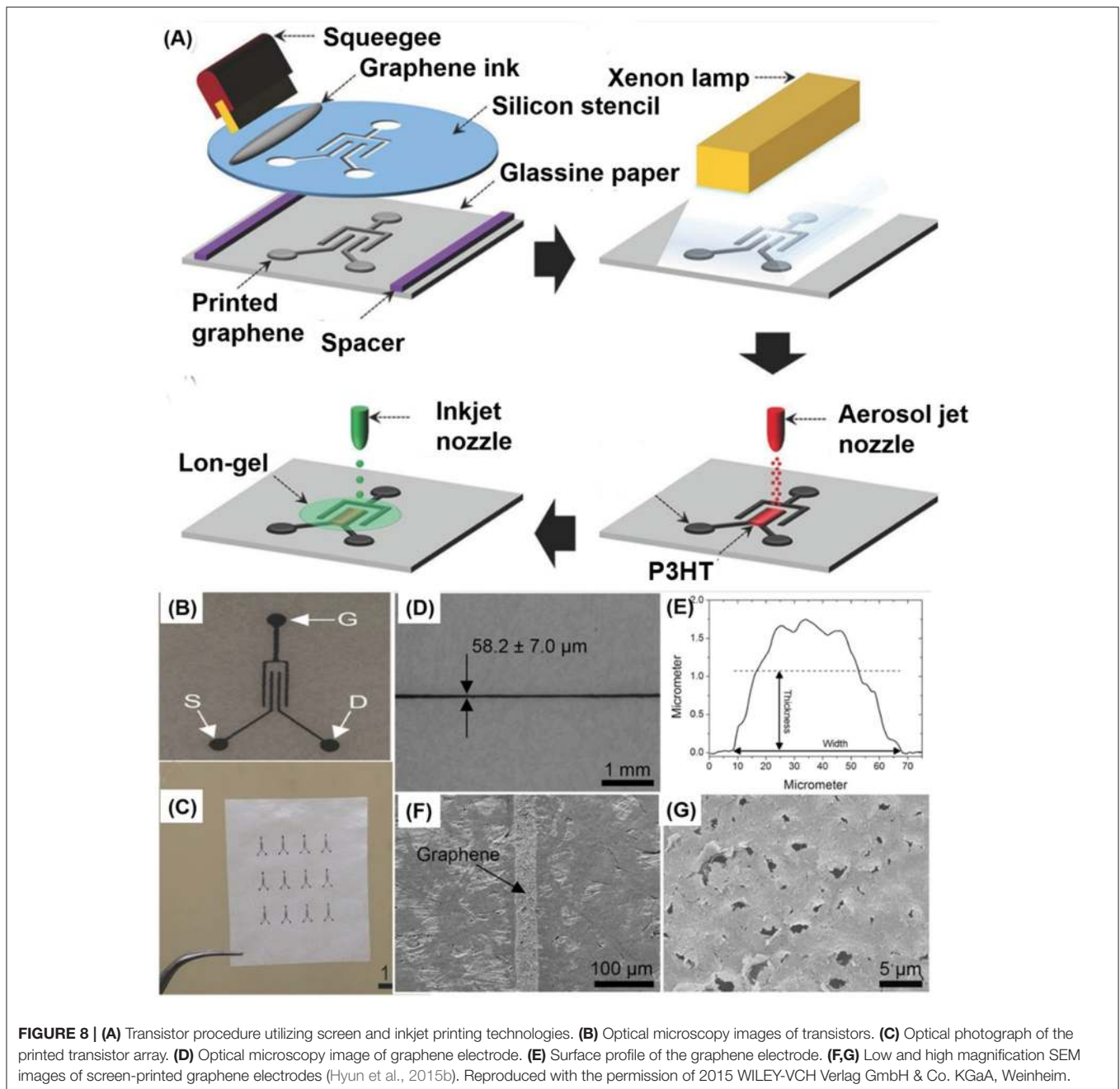
For some applications, a single printing technology cannot satisfy the need for a fabrication process, thus, a combination of printing technologies is desirable. The fabrication process of organic thin film transistors on flexible substrates is based on multiple printing technologies, including inkjet, and screen-printing technologies, as it shown in **Figure 8A**. First, the screen-printing ink used in this experiment was graphene ink, which has a high viscosity of ~ 70 Pa to prevent excessive spreading out of the substrate. The squeegee was made of silicon and the printed electrodes were exposed to a Xenon lamp to improve the conductivity of the graphene printed electrodes. The channel was deposited by aerosol-jet printing and the gate dielectric was deposited by the inkjet printing technology. Images of a single electrode and of multiple electrodes are shown in **Figures 8B,C**, respectively. The details of the flexible graphene electrodes are shown in **Figures 8D–G**. The width and thickness of the printed electrode fabricated by the silicon squeegee, with an opening of $30\ \mu\text{m} \sim 58.2 \pm 7\ \mu\text{m}$ and $1.11 \pm 0.9\ \mu\text{m}$, respectively, is illustrated in **Figures 8D,E**. By combining printing technologies, the advantages of various techniques can be fully applied.

Soft Lithography

Soft lithography is an effective method for fabricating patterned electrodes. Stefanie Lochmann et al. reported a novel way of manufacturing electrodes of micro capacitors based on soft lithography (Lochmann et al., 2018). **Figure 9A** shows the procedure of fabrication. A droplet of the precursor solution was spread over the substrate and the stamp was pressed into the precursor solution. After thermal treatment, the stamp was peeled off, thereby leaving the desired interdigital electrodes on the substrates. **Figures 9B,C** show the images of the interdigital carbon electrodes. Eduardo et al. reported a novel nanocomposite based on AgNWs, dispersed in poly(methyl methacrylate) with a sheet resistance below $10\ \Omega\ \text{sq}^{-1}$, an acceptable resistance for flexible electrodes (Martínez et al., 2016). The fabricated resistance, based on soft lithography, is shown in **Figures 9B,C**. The optical images of conductive tracks in the bright field mode and dark field mode are displayed in **Figures 9D,E**, respectively. The length of the electrode is $\sim 100\ \mu\text{m}$.

THE BOTTOM-UP TECHNOLOGIES OF PRINTED ELECTRODES

In addition to the physical methods of depositing or printing conductors on substrates, chemical methods are also employed. In contrast to transferring ink onto substrates physically, bottom-up methods involve the chemical reaction that occurs on the



surface, strengthening the connection between the electrodes and substrates. Here, two main chemical methods are reviewed.

Polymer-Assisted-Deposition (PAMD)

The full solution processing strategy, polymer-assisted metal deposition (PAMD) is employed for the fabrication of flexible bendable and stretchable metal (especially Cu) electrodes on flexible substrates. Figure 10A is an illustration of PAMD and its applications. The applications of polymer-assist-deposition mentioned, are the same as those shown in Figure 9A. Within polymer-assist-deposition technology, the polymer bonds to the substrates chemically or physically by three main

methods: surface-initiated polymerization, *in situ* free radical polymerization and polymer self-crosslinking, as shown in Figure 10A. The bonds ensure that the polymer layer attaches to the substrates tightly and do not fall out during the steps that follow. The metal thin film on the stretchable substrate that functions as an electrode, is shown at the top of Figure 10A. Working with the matrix-assisted catalytic printing (MACP) method, polymer-assist-deposition demonstrates its ability to fabricate patterned metal electrodes, as shown at the bottom left of Figure 9A. Polymer-assist-deposition is also capable of fabricating 3D stretchable and compressible sponges, as shown at the bottom right of Figure 10A. The process of

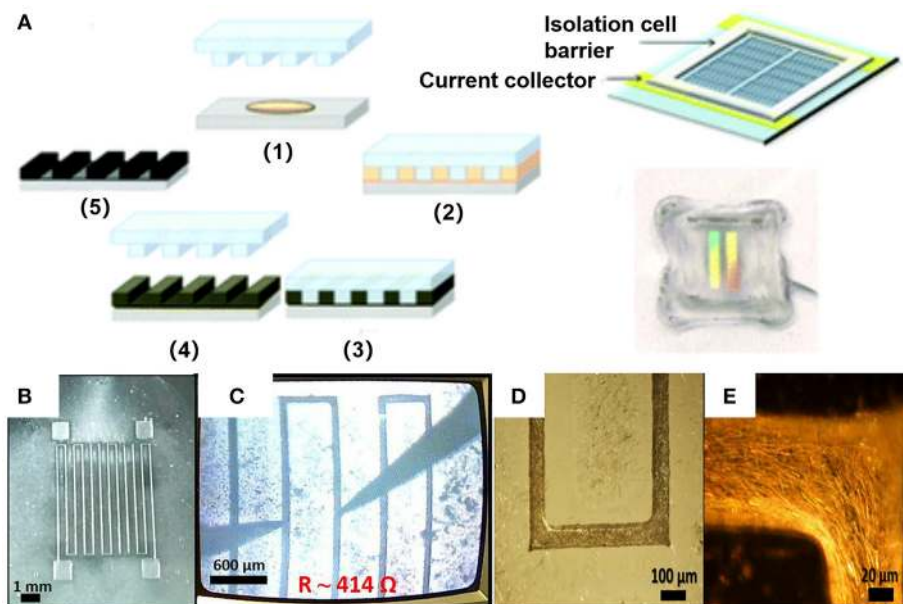


FIGURE 9 | (A) Schematic diagram of the electrodes utilized soft lithography method (Lochmann et al., 2018). Reproduced with the permission of 2018 Royal Society of Chemistry. **(B)** The optical images of fabricated electrodes **(B)** Optical images of flexible conductive electrodes. **(C)** Measurement of conductive trace. Optical images in bright field mode and dark field mode shown in **(D,E)**, respectively (Martinez et al., 2016). Reproduced with the permission of 2016 IOP Publishing Ltd.

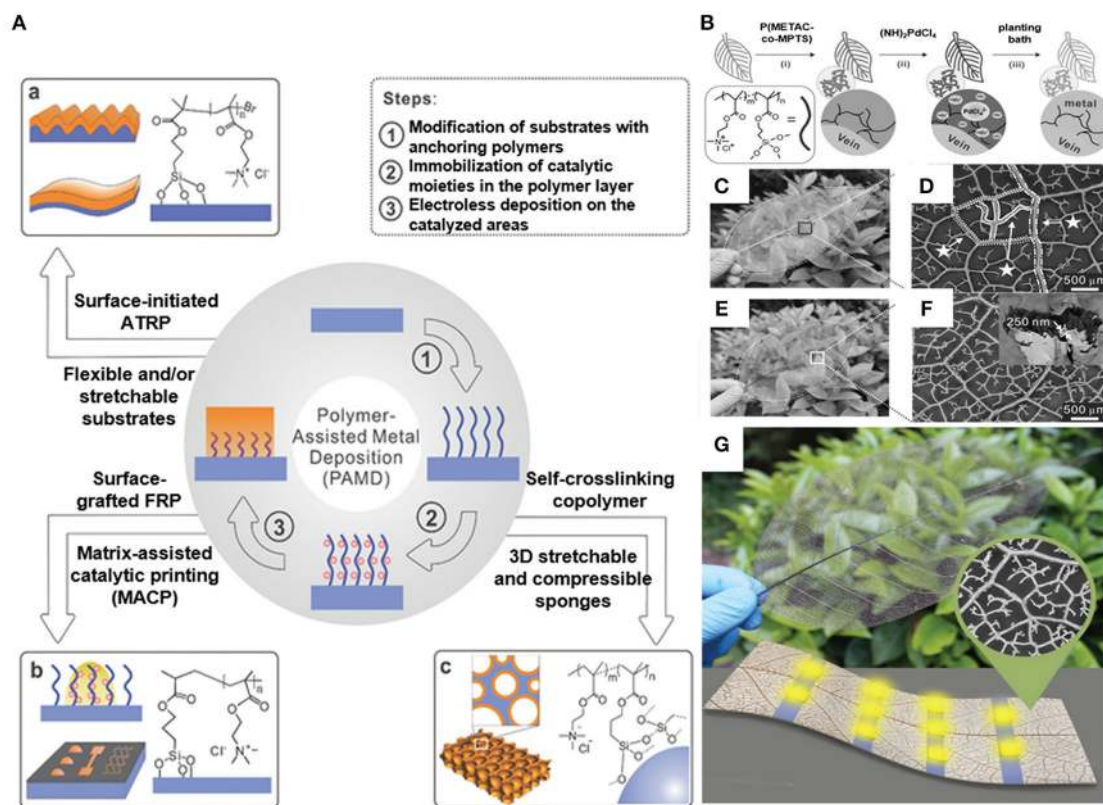


FIGURE 10 | (A) Schematic illustration of polymer-assisted metal deposition and its various applications, including patterned metal electrodes and metal sponges (Yu et al., 2014). Reproduced with the permission of 2014 WILEY-VCH Verlag GmbH & Co. KGaA, Weinheim. **(B)** Fabrication process of vein-based transparent electrodes. **(C,D)** SEM images of natural veins. **(E,F)** SEM images of vein-based transparent electrodes. **(G)** Optical photograph of vein-based electrodes (Yu et al., 2015a). Reproduced with the permission of 1999–2018 John Wiley & Sons, Inc.

metal deposition contains three main steps: modification of substrates, immobilization of catalytic moieties and deposition of electrodes. Based on PAMD, metal electrodes, patterned interconnects, and metal sponges can be manufactured. A combination of the PAMD and inspiration from natural vein and vein-like transparent electrodes was reported by Yu et al. (2015a) **Figure 10B** demonstrates the procedure of depositing Cu on the natural vein. Digital and SEM images of natural veins and vein electrodes are shown in **Figures 10C–E**, respectively. The transparent electrodes maintain the hierarchical structures of the veins with a thickness of metal Cu ~ 250 nm. **Figure 10F** illustrates the feasibility of flexible electrodes by illuminating an array of LED with a bulk resistance of $\sim 4 \Omega$. Embedded within the substrates, the electrodes fabricated by the means of PAMD possess a greater flexibility and adhesion with the substrates, than the electrodes did using physical methods. In addition, the electrodes also show a high nanoscale resolution and high conductivity over 10^5 S cm^{-1} . **Figure 10G** is the optical image transparent electrodes and the natural leaves, showing it high transparency.

Ion-Exchange Technology

As a bottom-up method, the ion-exchange fabrication makes use of the mechanism of replacement reaction between K^+ and Ag^+ and the reduction of Ag^+ with the deposited metal in the desired zone of PI. **Figure 11A** shows a diagram of flexible Ag electrodes via hydrolysis, ion-exchange, and thermal treatment steps. After the immersion in KOH solution, the surface of polyimide was embedded with K^+ ions and then modified with acrylic acid polymers (PAA). Ion-exchanges of K^+ into Ag^+ are achieved by immersing the substrate in a solution of AgNO_3 and $\text{NH}_3 \cdot \text{H}_2\text{O}$. The patterned Ag electrodes are obtained in two different ways. First, the KOH modified PI substrates are pasted flatly onto the paper and inkjet printing, with carbon ink, is used as the mask for the reduction of Ag^+ ions into silver atoms in a H_2O_2 solution. Secondly, the inkjet printed PI films are thermally cured in an air oven. **Figure 11B** shows an optical image of flexible Ag electrode arrays on PI. The ability to be printed in an array can accomplish numerous functions. One single interdigital electrode cell is comparable to the size of a coin. **Figures 11C,D** show the different morphology of electrodes before and after Au coating. Besides the relatively simple fabrication steps mentioned, the cost of the fabrication process is low and does not require sophisticated devices and an ultra-clean environment. Additionally, the fabrication process produces no air or water pollution and has a low power consumption. One step mask technology simplifies procedures of patterned electrodes, while the conductivity and thickness of the electrodes can be controlled by adjusting the time of the ion-exchange reaction and the concentrations of the KOH and H_2O_2 solution employed during the procedure. Similarly, in polymer-assisted-deposition, the adhesion between the electrodes and flexible PI substrate is strong. The full-solution process eliminates pollution possibilities of air; hence, the formed metal electrodes are compact. Further, the ion-exchange reaction only takes place on the surface of the PI substrates, while the middle part of the PI substrates remain unaffected because of its mechanical

strength and stability. On the basis of printed electrodes, graphene/graphene oxide pressure sensitive film arrays are placed on the PI substrates, thereby fabricating an advanced electric blanket shown in **Figures 11E,F**. These pressure sensors operate at a constant voltage. When the sensor experiences an exerted force, their resistance decreases, and the current increases. The increasing current and pressure could lead to heat generation. The infrared images reflect the temperature of the object. With loaded pressure, the corresponding infrared image is displayed in **Figure 11G**, illustrating the possibility of future application. Identical to the PAMD technology, the ion-exchange method fundamentally solves the problem of weak connections between electrodes and substrates while maintaining good conductivity and high solution.

Based on the traditional technology of Ag deposition on the substrate, composites of Ag and nanotubes can also be obtained to improve the performance of supercapacitors. **Figure 12A** shows a flow chart of micro-supercapacitors with Ag/multi wall nanotubes (MWNT) as interdigital electrodes. A clean PI substrate was immersed in a KOH solution and then covered with a photosensitive film. With a patterned inkjet printed electrode film as a mask, the prepared composite of PI and photosensitive film was exposed to air and then immersed in NaCO_3 to form the patterned electrodes on the film. Ion-exchanges take place when the mask-protected PI film is soaked in $\text{Ag}(\text{NH}_3)_2^+$ and an H_2O_2 solution stepwise. The PI and Ag electrodes are then dipped into the MWNT solution and air dried. The patterned photosensitive film is removed, leaving the interdigital electrodes of Ag/MWNT on PI. **Figures 12B,C** are optical images of the fabricated electrodes on the PI being bent. After being bent, the electrodes stuck to the substrate without a gap. As shown in the SEM image in **Figure 12D**, the electrodes were embedded in the surface of the substrate, leading to good bending reliability while the profile of the electrodes was also clear and well defined. **Figure 12E** shows an optical microscopy image of the electrodes. The patterns of the electrode are well defined without deformation and the width is $\sim 100 \mu\text{m}$. In the SEM image of the Ag micro current collector fabricated with the ion-exchange method shown in **Figure 12F**, the thickness measures ~ 200 nm. **Figure 12G** illustrates the comparison of conductivity among the bulk Ag, fabricated Ag film using the ion-exchange method and WMNTs. The measured conductivity of the Ag film is $\sim 1.68 \times 10^5$ S cm^{-1} , which is much higher than that of WMNTs and comparable with that of the Ag bulk. Based on the details discussed above, the technical parameters of different technologies are listed in **Table 1**.

SUMMARY

The fabrication of flexible electrodes applied to flexible electronics, can be classified into two fabrication process categories: top-down and bottom-up. Top down technology uses physical procedures to deposit organic and inorganic materials onto the substrate directly. The conventional methods possess a high solution and high conductivity. For screen and inkjet printing technologies, the one-step transfer of functional ink

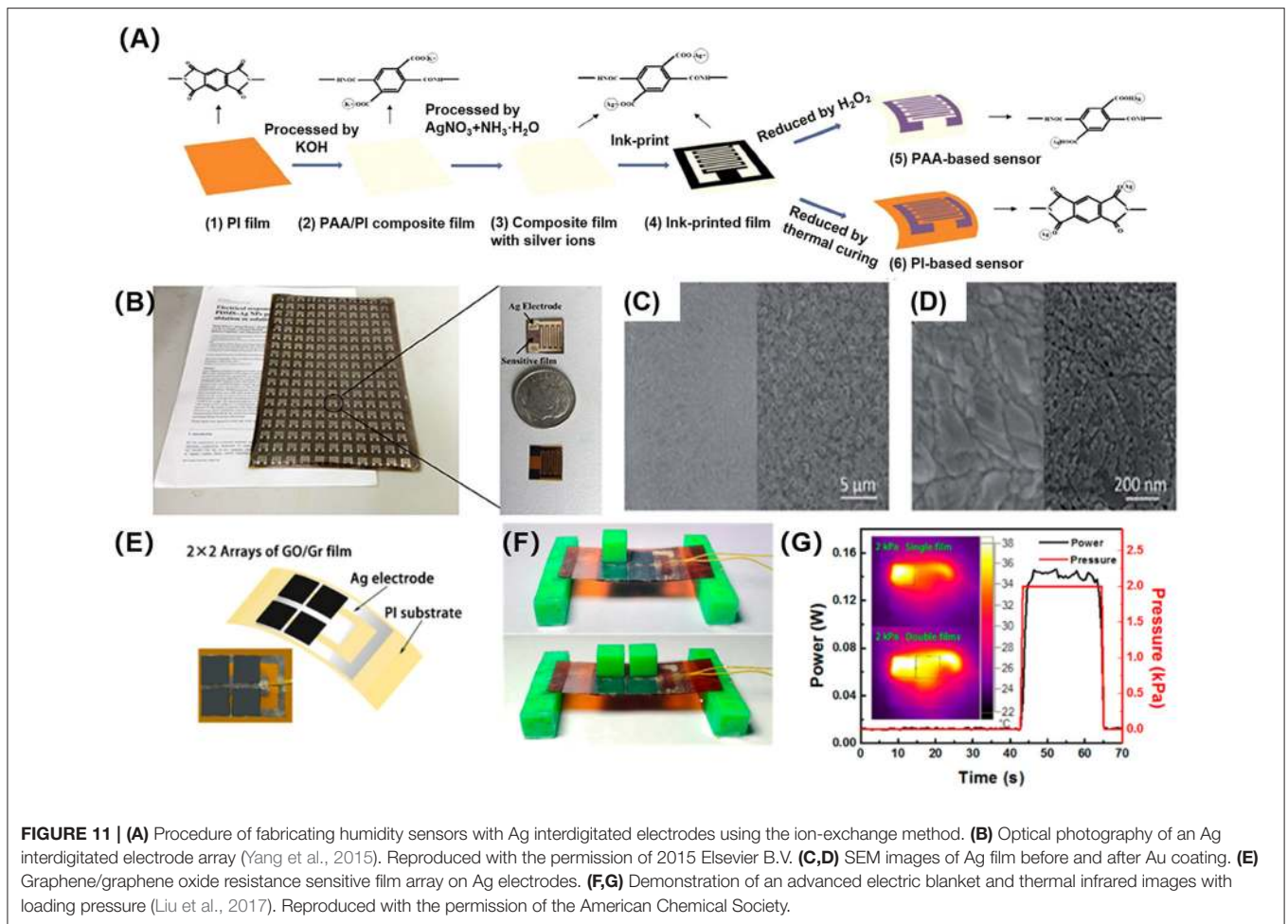


FIGURE 11 | (A) Procedure of fabricating humidity sensors with Ag interdigitated electrodes using the ion-exchange method. (B) Optical photography of an Ag interdigitated electrode array (Yang et al., 2015). Reproduced with the permission of 2015 Elsevier B.V. (C,D) SEM images of Ag film before and after Au coating. (E) Graphene/graphene oxide resistance sensitive film array on Ag electrodes. (F,G) Demonstration of an advanced electric blanket and thermal infrared images with loading pressure (Liu et al., 2017). Reproduced with the permission of the American Chemical Society.

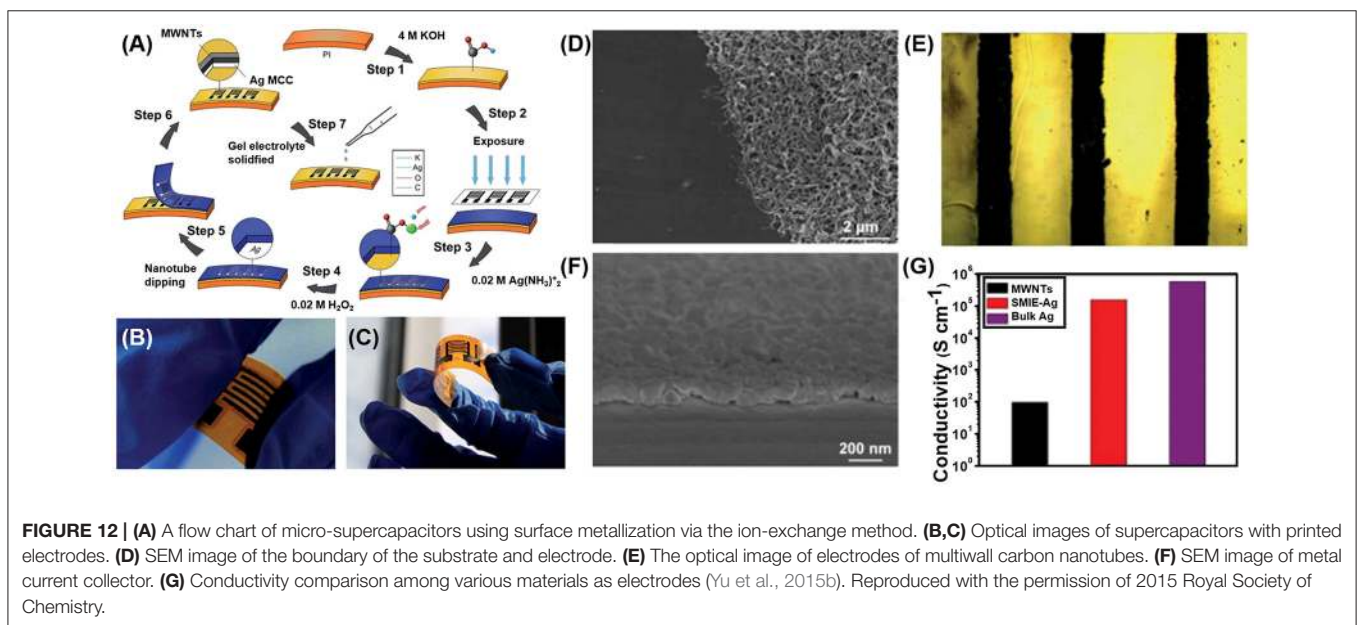


FIGURE 12 | (A) A flow chart of micro-supercapacitors using surface metallization via the ion-exchange method. (B,C) Optical images of supercapacitors with printed electrodes. (D) SEM image of the boundary of the substrate and electrode. (E) The optical image of electrodes of multiwall carbon nanotubes. (F) SEM image of metal current collector. (G) Conductivity comparison among various materials as electrodes (Yu et al., 2015b). Reproduced with the permission of 2015 Royal Society of Chemistry.

TABLE 1 | Technical specifications of flexible electrode technologies.

	Thermal deposition	Sputtering	Dip-pen	Screen printing	Inkjet printing	Soft lithography	PDMA	Ion-exchange
Strategy	Top-down	Top-down	Top-down	Top-down	Top-down	Top-down	Bottom-up	Bottom-up
Physical/Chemical Process	Physical process	Physical process	Physical process	Physical process	Physical process	Physical process	Chemical process	Chemical process
Materials of electrodes	Metal (Kim et al., 2018)	Metal (Kim et al., 2018)	Metal and conductive polymer	Ink of organic and inorganic materials (Hyun et al., 2015b; Khan et al., 2015; Lu et al., 2017)	Ink of organic and inorganic materials (Hyun et al., 2015b; Dankoco et al., 2016; Zhang et al., 2018)	Ink of inorganic and organic materials	Cu, Ag, Au, Ni, Pt (Yu et al., 2014, 2015b)	Ag, Cu (Yang et al., 2015; Yu et al., 2015b)
Thermal treatment	High T	High T	Low T	High T	High T	High T	Room T	Room T
Conductivity	10^5 S cm^{-1}	10^5 S cm^{-1}	10^5 S cm^{-1}	$10^3\text{-}10^5 \text{ S cm}^{-1}$	$10^3\text{-}10^5 \text{ S cm}^{-1}$		$10^4\text{-}10^5 \text{ S cm}^{-1}$	10^5 S cm^{-1}
Adhesion	Poor to very good	Poor to very good	Poor to very good	Poor to very good	Poor to very good	Poor to very good	Excellent	Excellent
Resolution	nm	nm	nm	μm	μm	μm	nm- μm	μm
Cost	High	High	High	Low	Low	Low	Low	Low
Flexibility	Good	Good	Good	Good	Good	Good	Good	Good

onto a substrate saves on costs, whereas bottom-up technologies, including PAMD and ion-exchange, produces an obvious advantage of strong adhesion between metal and substrates at their surface, as a consequence of their interpenetration.

PERSPECTIVE

Although existing fabrication technologies promise to meet the requirements of flexible electrodes utilized in flexible electronic devices, challenges remain to obtain a low-cost, high-resolution, high-throughput, and high-conductivity manufacturing process.

High temperature treatment in conventional fabrication technologies. In top-down methods of the fabrication process, physical evaporation and deposition requires the metal to evaporate in order to be deposited, and the printing technology requires a sintering process to improve conductivity. Among all the procedures mentioned above, thermal treatment is indispensable, in other words, the cost is relatively higher for thermal treatment than the cost for bottom-up methods. Obtaining a low cost method therefore remains a great challenge for these technologies.

The choice and synthesis of ink in screen and inkjet printing technologies. The ink plays an important role in printing technologies because of its responsibility of solution, conductivity, and adhesion to the substrates. Many organic and inorganic materials have been used to fabricate flexible electrodes, and the improvements in high resolution and high conductivity are future goals.

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The breakthrough in metal limitations. Bottom-up technologies that take advantage of a catalyst or reduction reaction to embed metal into the surface of substrate surface, are limited by the finite choice of metals. Various metals need to be deposited on substrates to explore their corresponding performances.

The compatibility with roll-to-roll technology. Mass production is the terminal target of printed electronics, which feature low cost and high output, thus, compatibility with roll-to-roll technology are significant. Both the top-down and bottom-up technologies should take mass production compatibility into consideration.

AUTHOR CONTRIBUTIONS

XW and JZ conceived and designed structure of the review. QuL, JZ, QiL, GL, XT, ZL, and FQ wrote the manuscript. All authors contributed to the discussion and commented on the manuscript.

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Conflict of Interest Statement: The authors declare that the research was conducted in the absence of any commercial or financial relationships that could be construed as a potential conflict of interest.

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